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a second interconnect selectively provided on the second interlayer insulating film and electrically connected to the first interconnect through a second contact hole formed in the second interlayer insulating film; and

a passivation layer provided so as to cover the second interconnect.

	Please add the following new claim 28:
1	28. (Newly Added) A semiconductor device, comprising:
2	a capacitor provided on a supporting substrate having an integrated
3	circuit thereon and including a lower electrode, a dielectric/film, and an upper
4	electrode;
5	a first interlayer insulating film provided/so as to cover the
6	capacitor;
7	a first interconnect selectively provided on the first interlayer
8	insulating film and electrically connected to the integrated circuit and the
9	capacitor through a first contact hole formed in the first interlayer insulating
10	film;
u_	a second interlayer insulating film provided so as to cover the first
12	interconnect;
13	a hydrogen supplying layer provided between the first interconnect
14	and the second interlayer insulating film excluding an area in which the capacitor
15	is provided, said hydrogen supplying layer having a sufficient amount of
16	hydrogen for repairing damage done to the integrated circuit caused in forming
17	the first contact hole;
18	a second interconnect selectively provided on the second interlayer
19	insulating film and electrically/connected to the first interconnect through a
20	second contact hole formed in the second interlayer insulating film; and

a passivation layer provided so as to cover the second interconnect.